

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):      Kyoung-Ju SHIN et al.  
Assignee:          Samsung Electronics Co., Ltd.  
Title:                THIN FILM DIODE PANEL AND MANUFACTURING METHOD  
                             OF THE SAME  
Application No.:    10/578,028                      Filing Date:            April 27, 2006  
Examiner:          Thanh Nhan P. NGUYEN      Group Art Unit:        2871  
Docket No.:        PANK01883 US                  Confirmation No.:       9578

September 23, 2009

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated June 23, 2009, Applicants submit the following remarks and request reconsideration.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 6 of this paper.